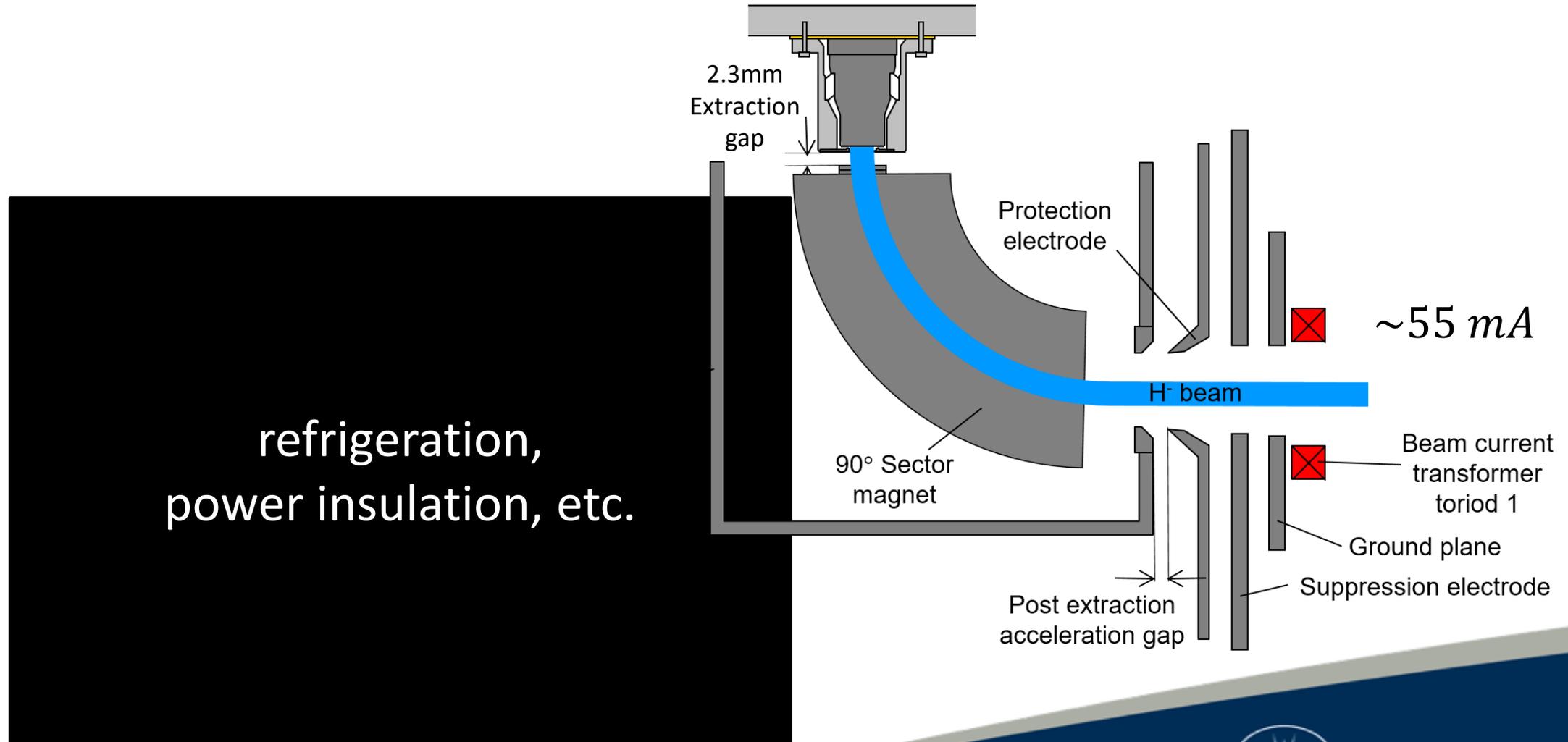


# Caesium vapour capture experiments using POCO CZR-2 graphite

Tiago Sarmento

S. Lawrie, O. Tarvainen, D. Faircloth,  
J. MacGregor, R. Abel, M. Whitehead, T. Wood

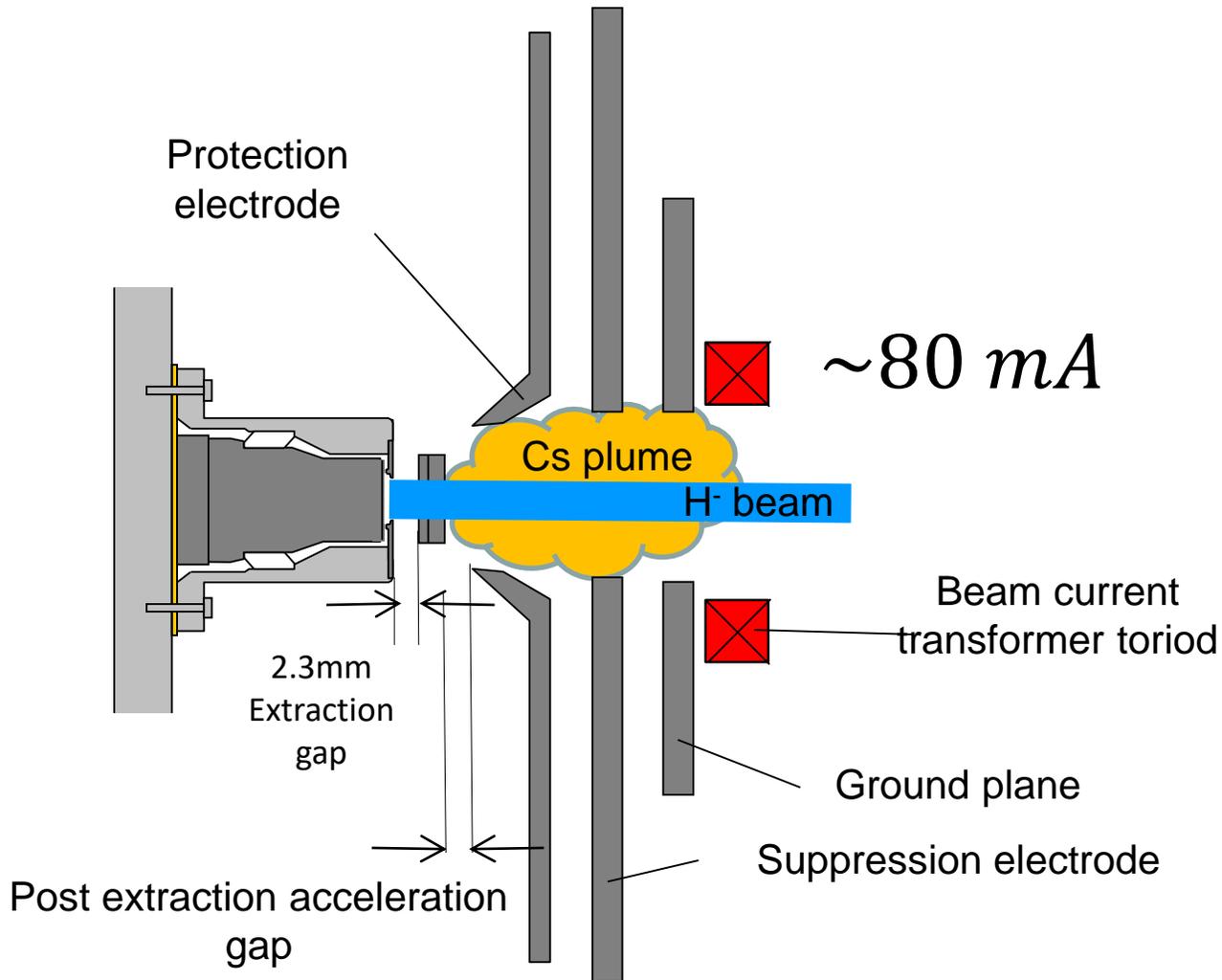
# Current operational source on ISIS



# Current operational source on test stand

Keeping all operating settings the same, but removing the cold box:

$\sim 55 \text{ mA} \rightarrow \sim 80 \text{ mA}$

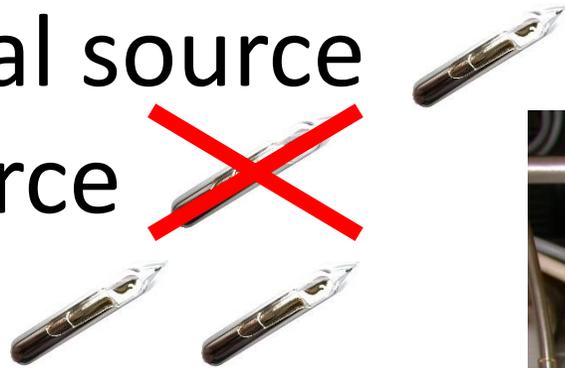


# Grubby cold box

Operational source

~~RF ion source~~

2X source



Require new caesium capture mechanism!





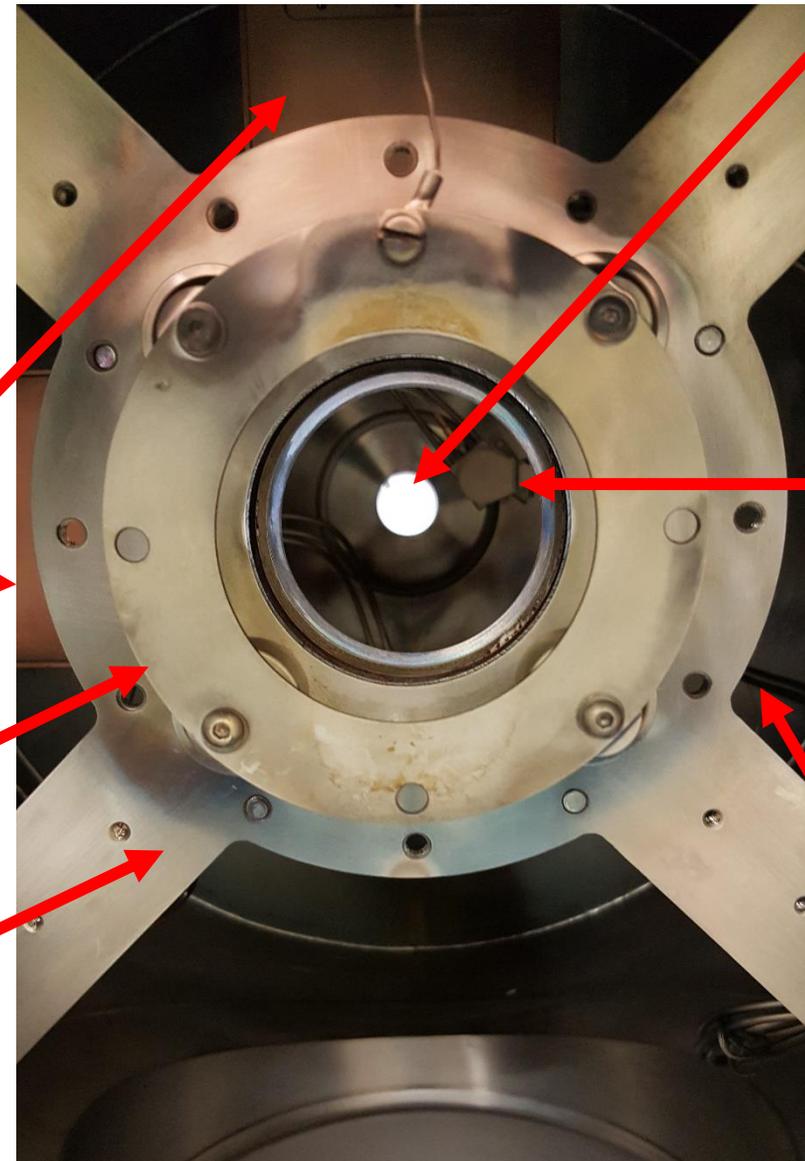
# Vessel for Extraction and Plasma Source Analyses (VESPA)

View from ion source

Emittance  
scanners

Protection  
electrode

Lab ground



Optical  
fibre and  
spectro-  
meter

QCM

Toroid

# Caesium diagnostics: QCMs

- Quartz Crystal Microbalance:
  - Measures mass deposit on surface from shift in resonant frequency

$$\Delta m$$

$$\Delta f$$

using the Sauerbrey relation:  $\Delta f \propto -\Delta m$

- Calculates the accumulation rate in the vessel

Time resolution  $\sim 1s$  → doesn't distinguish caesium escaping during or between pulses



# Caesium diagnostics: Spectrometer

- Broadband spectrometer:
  - Simultaneously measures intensity of several wavelengths using a prism and array of CCD chips

Only captures information during plasma pulses

Time resolution  $\sim 500 \mu\text{s}$  → doesn't reveal structure of pulse



# Caesium capture requirements

- Capture  $\sim 5$  g in a month
- Ideally minimise ancillary equipment

→ chemical capture

→ graphite

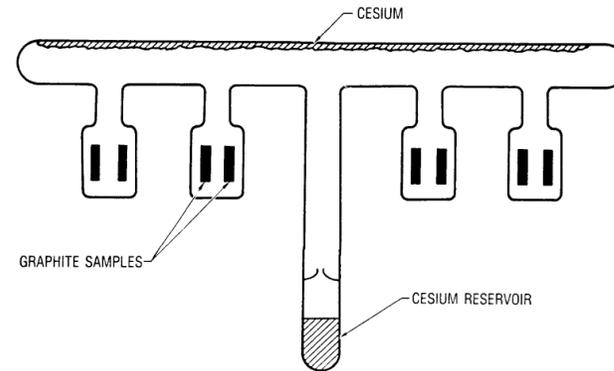
used in caesium clocks

comes in different grain sizes  
and porosities

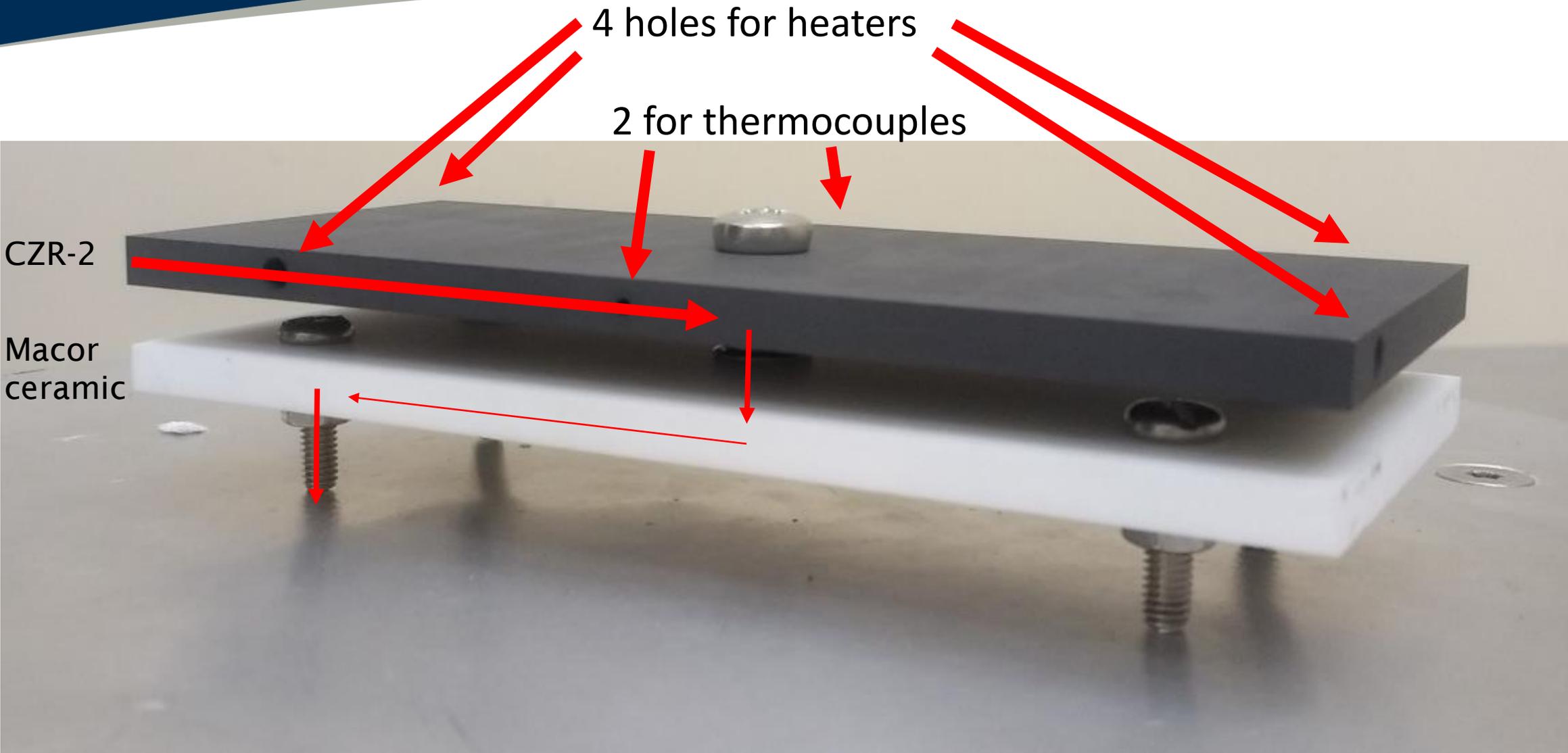


# Graphite design

- Bhaskar et al ('88) found POCO CZR-2 graphite to be most effective, capturing 20% its own mass



- Want to bake in situ, and heat to experiment at various temperatures
- ANSYS to ensure sufficient thermal isolation to hold 500 °C without too much heating to the rest of the vessel

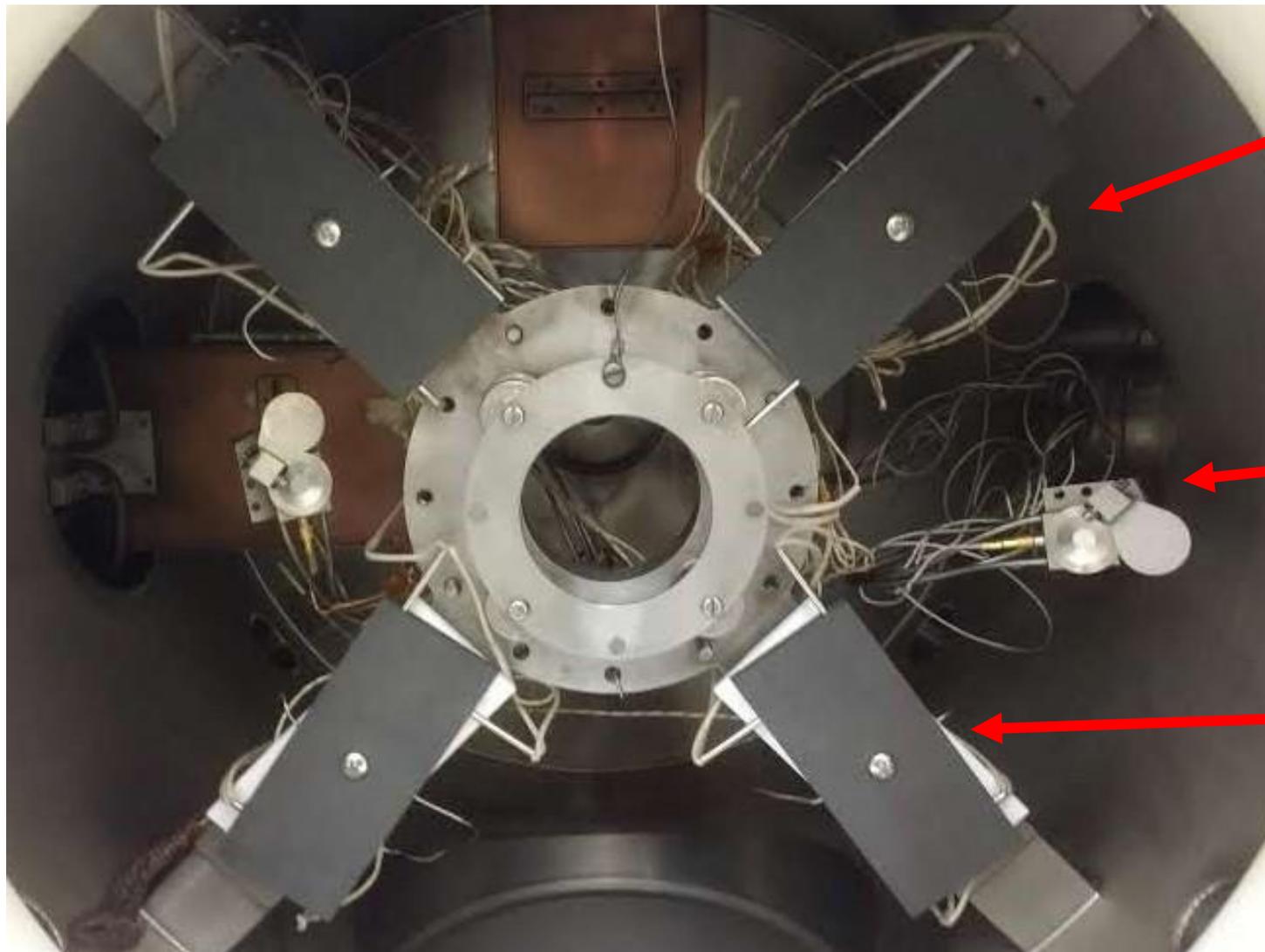


4 holes for heaters

2 for thermocouples

CZR-2

Macor  
ceramic



'Firerod' heaters  
operate up to 350 °C

QCMs



# Graphite design (2)

- Heaters are in series pairs to provide some redundancy
- Redundant thermocouple on each block also minimises need to open vessel
- With current set up cannot be sure QCMs and optical fibre return to the exact same position after opening and closing vessel



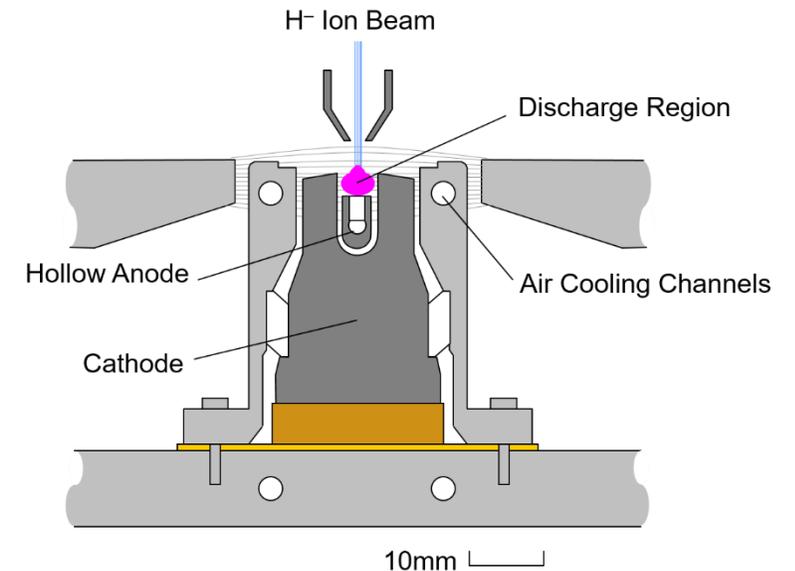
# Comparison with/without graphite

- Currently cannot compare absolute values with and without graphite
- Can see changes to data as graphite temperature is changed
- Must distinguish if changes are caused within source or by graphite
- Set of experiments to characterise effect of source changes on QCM and spectrum readings.



# Characterising experiments

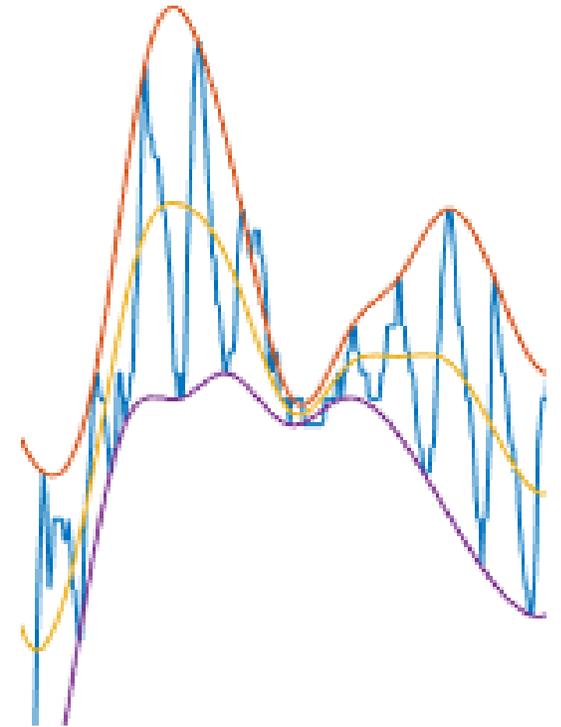
- 3 key independent variables on the source, with typical operating settings:
  - Oven temperature (159 °C)
  - Air flow (10.5 L/min) (Source cooling)
  - Discharge current (55 A)



- 3 experiments: run the source and change only one parameter

# Preparing QCM data

- Thickness is measured every second
- Accumulation rate is calculated
- Smoothed by taking:
  - a moving mean of 30 previous points
  - the mean of the peak envelope
- Normalised to first 100 points in an experiment



# Interpreting QCM data

- Accumulation rate depends on:
  - Deposition rate
  - Evaporation rate

→ sensitive to changes in distribution of caesium and temperature of the crystal

1 s time resolution → dominated by caesium escaping between pulses, and (possibly) from vessel surfaces



# Preparing spectrometry data

- $H_{\alpha}$  recorded with 300  $\mu\text{s}$  integration time to avoid saturation
  - Didn't go to plan
- $H_{\beta}$ , Caesium lines 852 nm, recorded with 1500  $\mu\text{s}$  integration time
- Smoothed by taking:
  - a moving mean of 30 previous points
- Normalised to first 100 points in an experiment



# Interpreting spectrometry data

- Assuming electron collisions are the only cause of emission:

$$I \propto n_e n_i \langle \sigma(v)v \rangle$$

$n_e$  - electron density

$n_i$  - species density

$v$  - electron velocity

$\sigma(v)$  - cross section as function of velocity

$$\frac{I_{H\alpha}}{I_{H\beta}} = \frac{\langle \sigma(v)v \rangle_{H\alpha}}{\langle \sigma(v)v \rangle_{H\beta}}$$

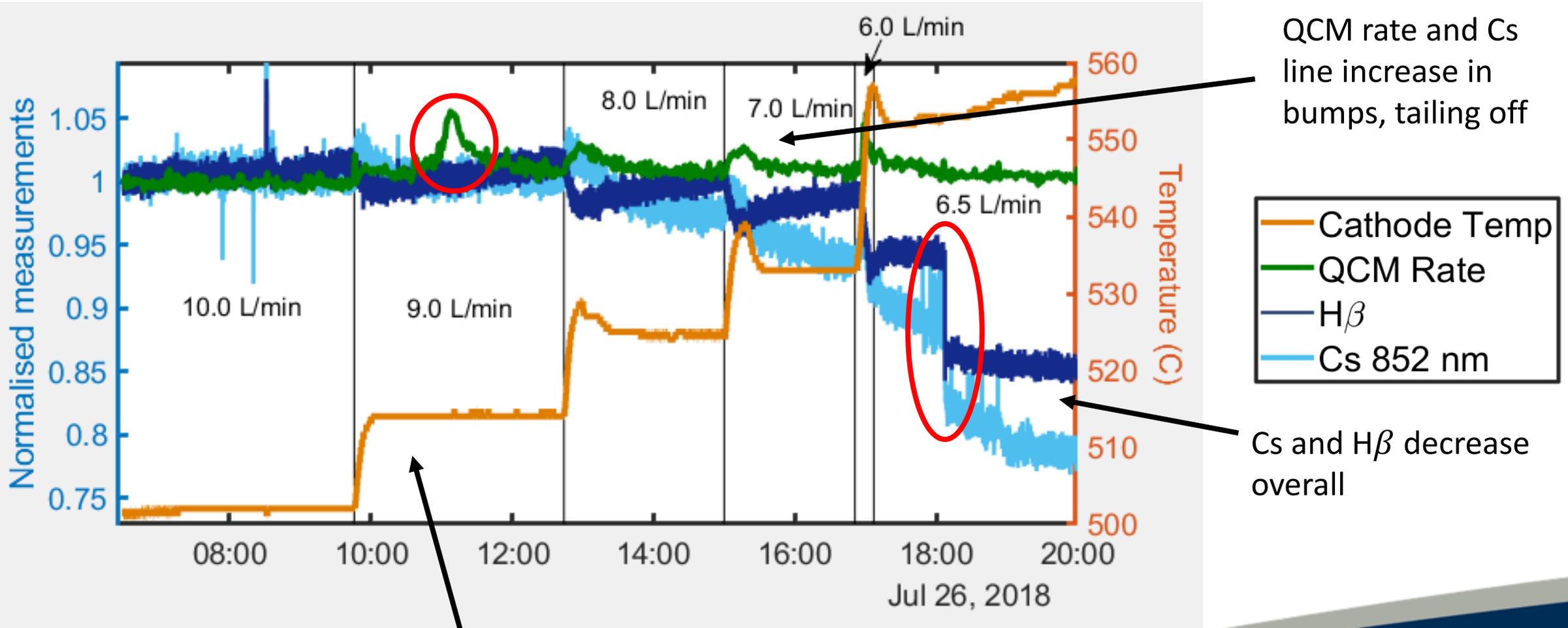
increases with electron energy, proxy for

voltage between anode and cathode if only primary electrons collide

$$\frac{I_{Cs\ 852\ nm}}{I_{Cs\ 894\ nm}} = \frac{\langle \sigma(v)v \rangle_{Cs\ 852\ nm}}{\langle \sigma(v)v \rangle_{Cs\ 894\ nm}} \approx \text{constant}$$



# Air Flow: Oven at 159 °C

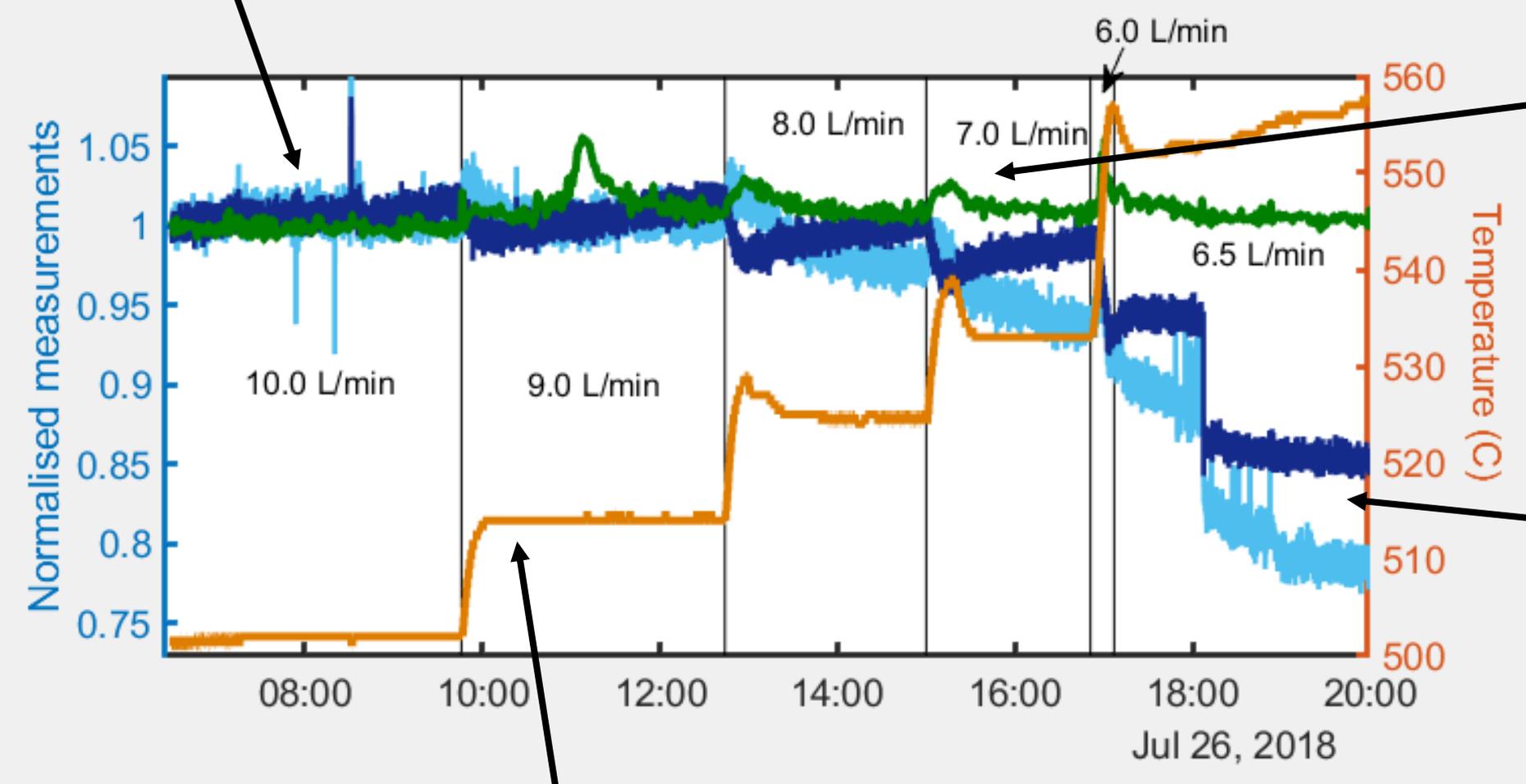


Cathode temperature increases in steps



Some caesium 'reservoir' exists on the source surfaces

# Air Flow: Oven at 159 °C (2)



Caesium fills first the plasma, then vessel, and temporarily increased rate

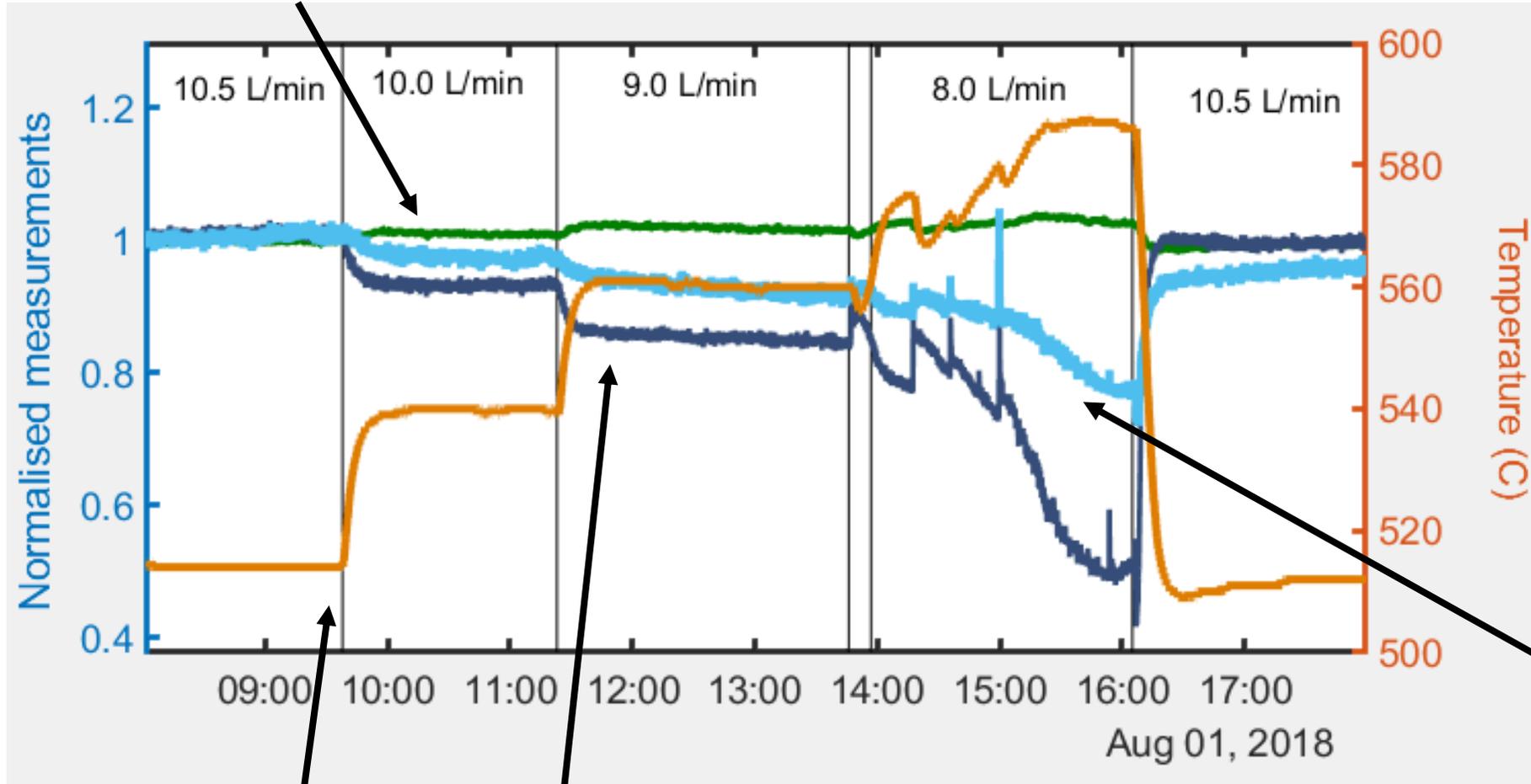
- Cathode Temp
- QCM Rate
- H $\beta$
- Cs 852 nm

Less caesium is available so signal drops  $e^-$  energy **increases** so cross sections drop

Temperature change shifts equilibrium size of the reservoir

# Air Flow: Oven at 171 °C

QCM increase in steps



Stability is lost

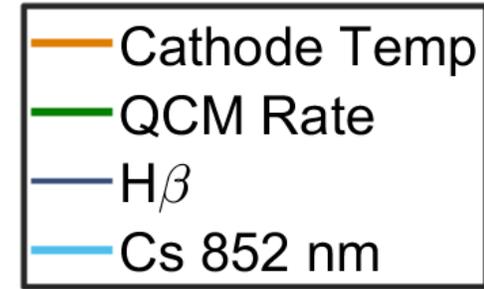
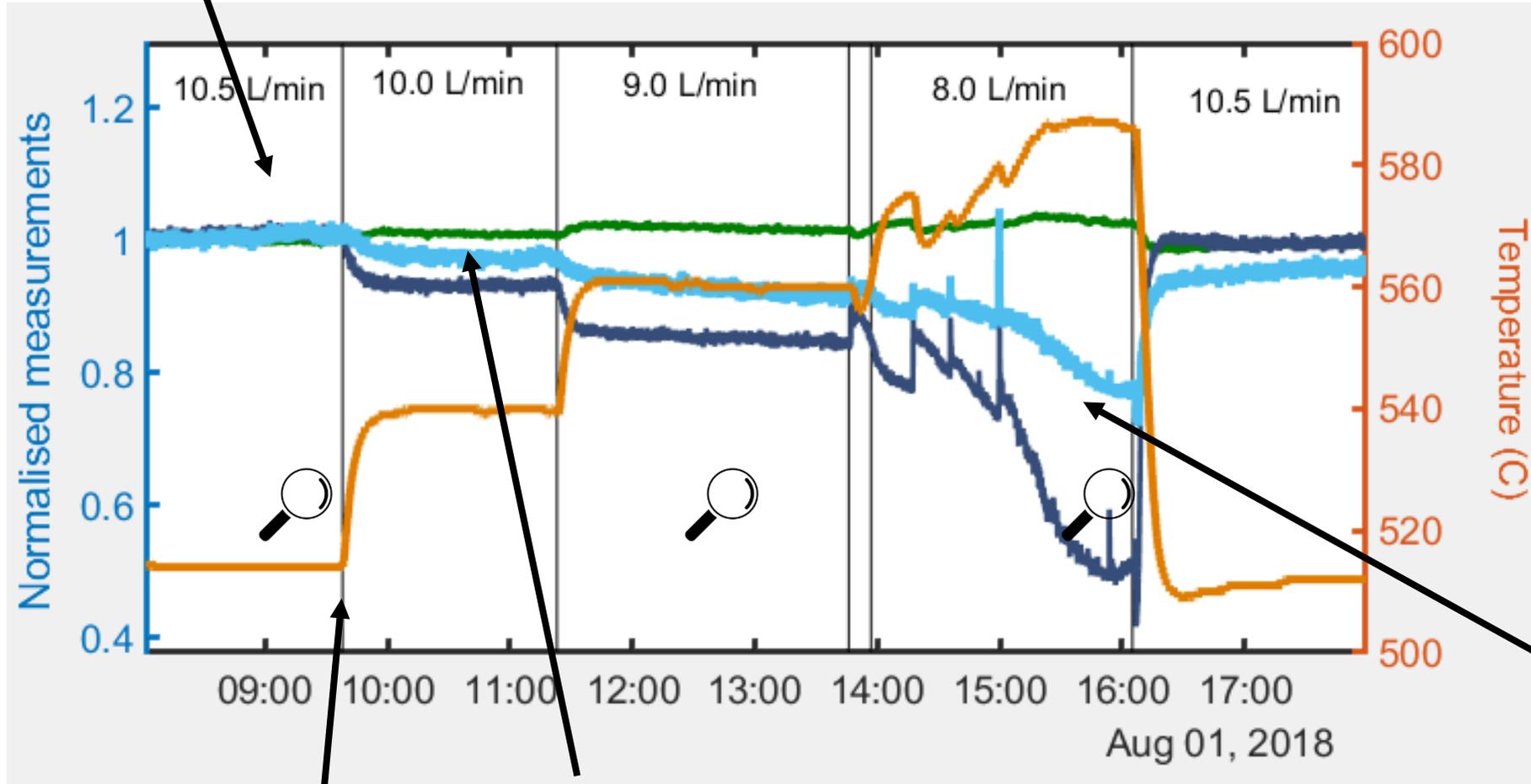
Cathode temperature increases in steps

Cs and H $\beta$  decrease in steps



Some caesium 'reservoir'  
exists on the source  
surfaces

# Air Flow: Oven at 171 °C

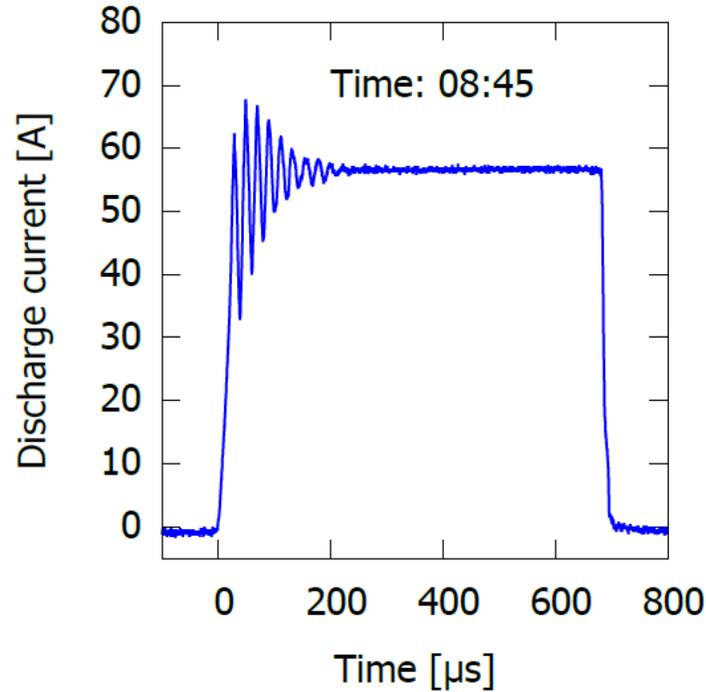


Reservoir is nearly  
depleted

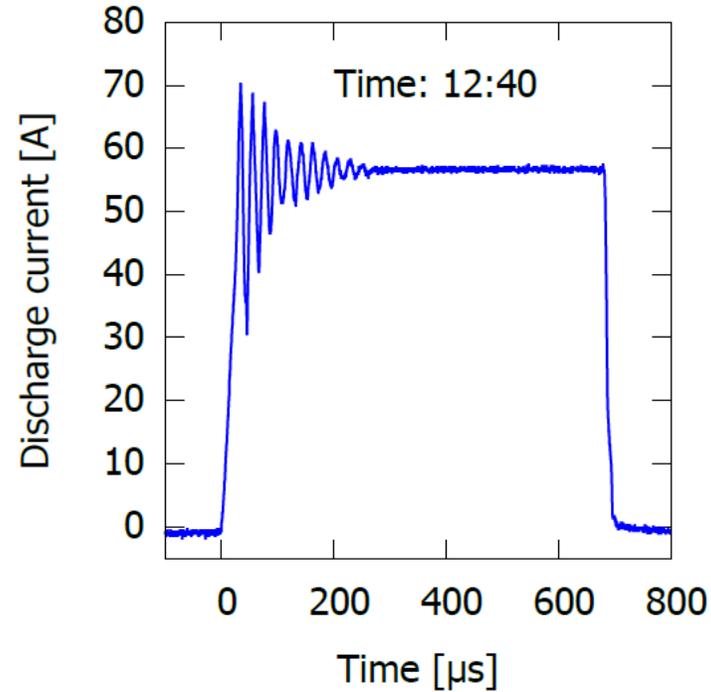
Temperature change  
shifts equilibrium size of  
the reservoir

Reservoir is replenished more  
rapidly, so drop off is much slower

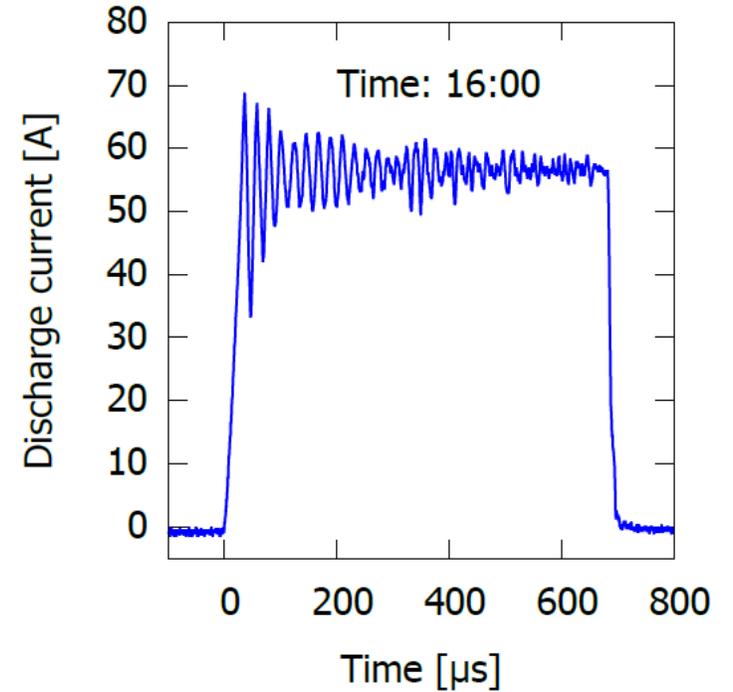
# Air Flow: Oven at 171 °C



10.5 L/min



9.0 L/min



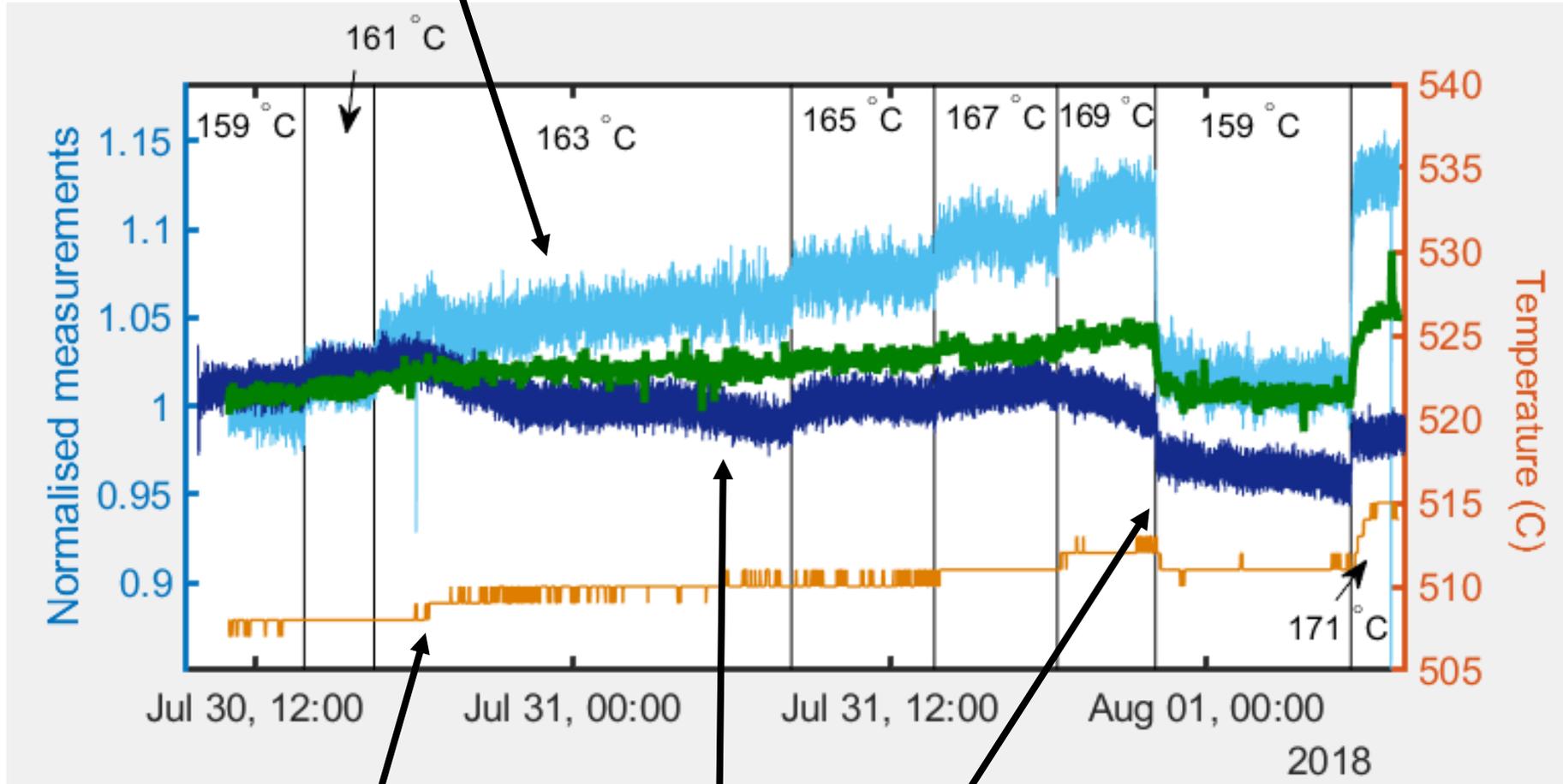
8.0 L/min

Noise appears gradually  
as caesium reservoir is depleted



Caesium line and QCM increase in steps

# Oven temperature



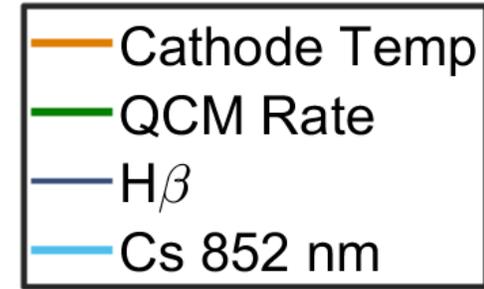
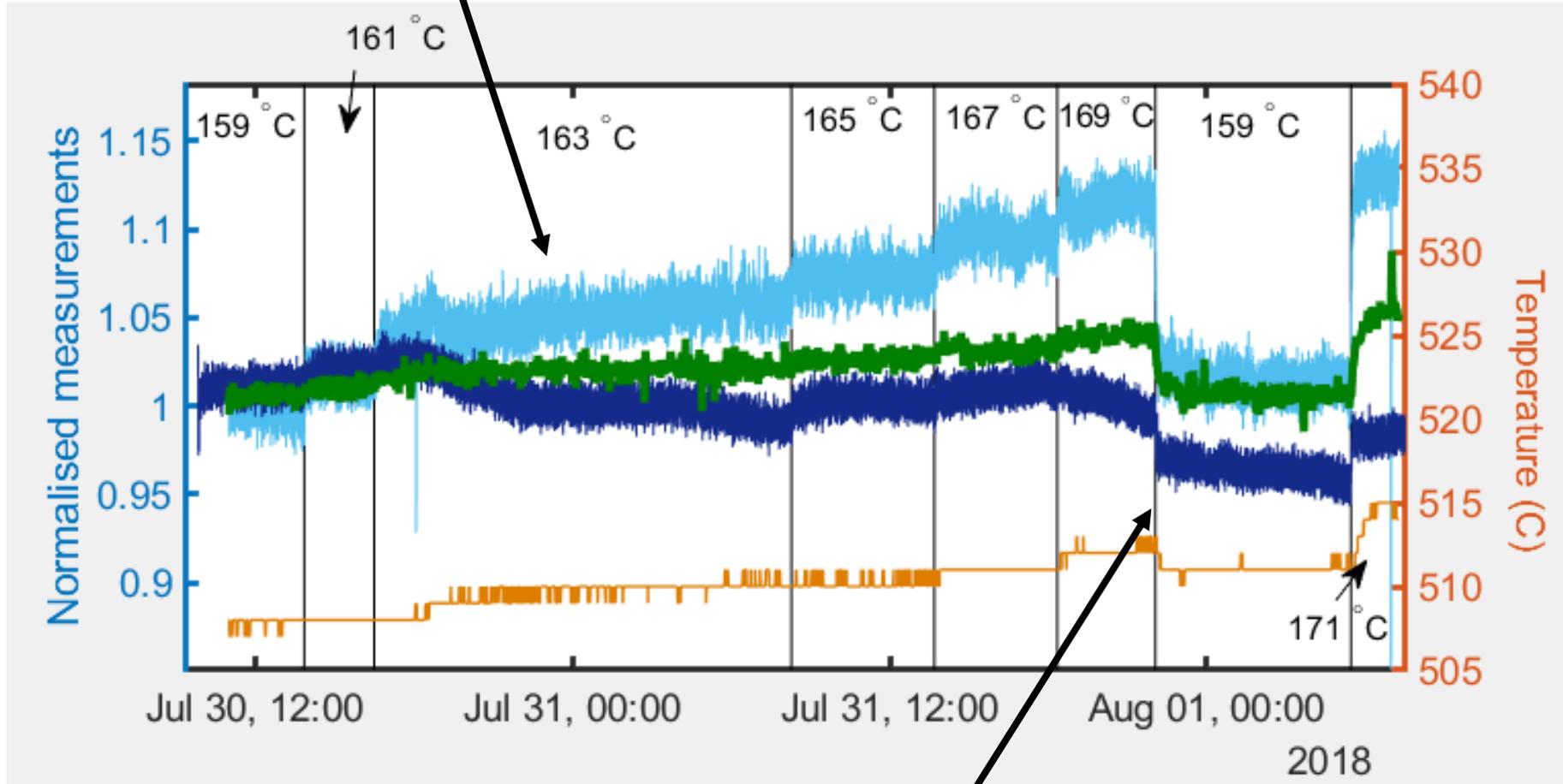
Cathode temperature doesn't change much

H $\beta$  doesn't display obvious trend except at biggest drop



# Oven temperature (2)

Caesium delivery rate increased



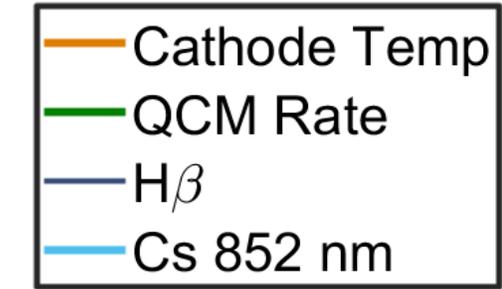
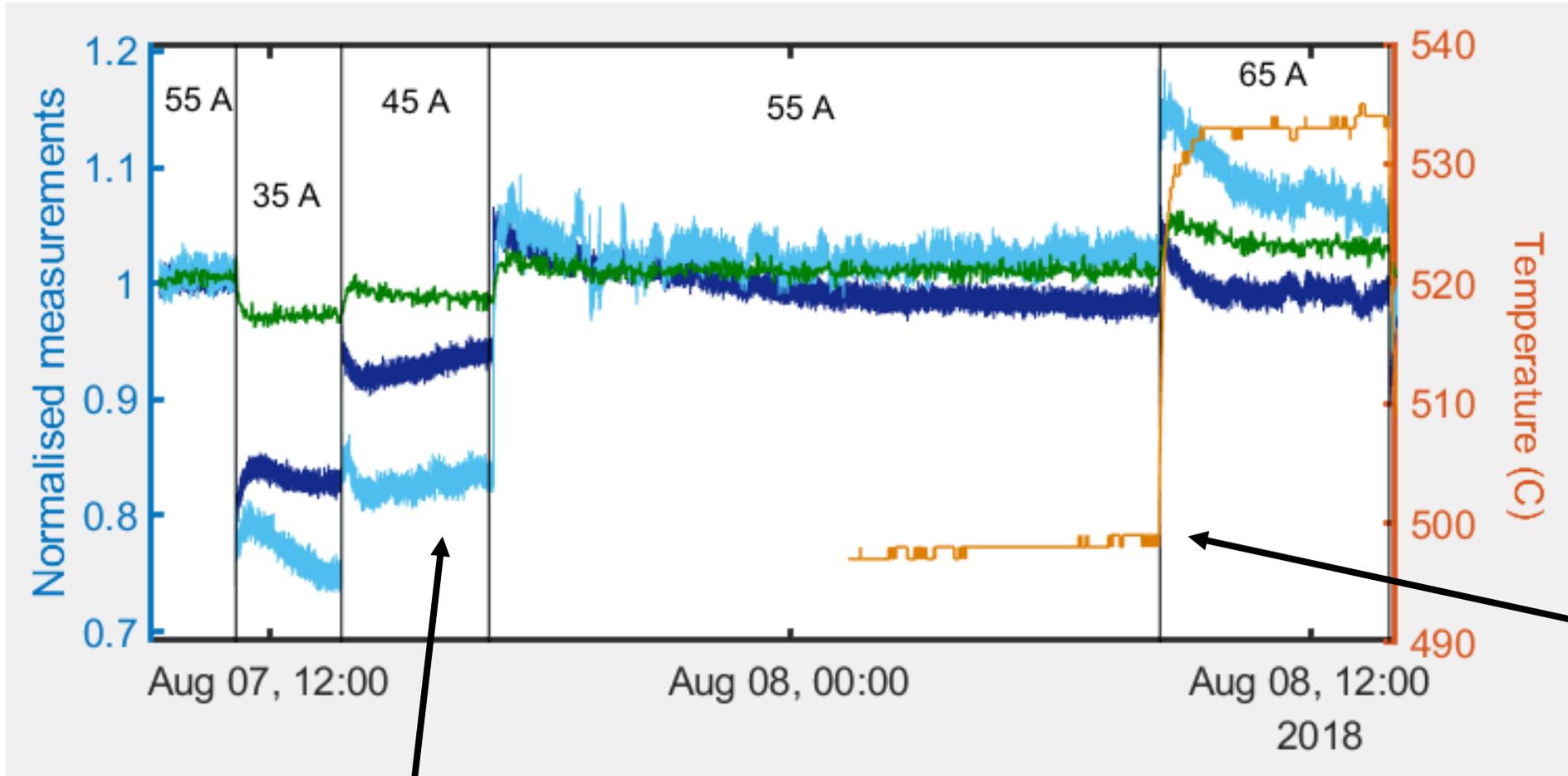
higher electron energy  
→ lower cross section



Less caesium results in arc  
voltage increase



# Discharge current



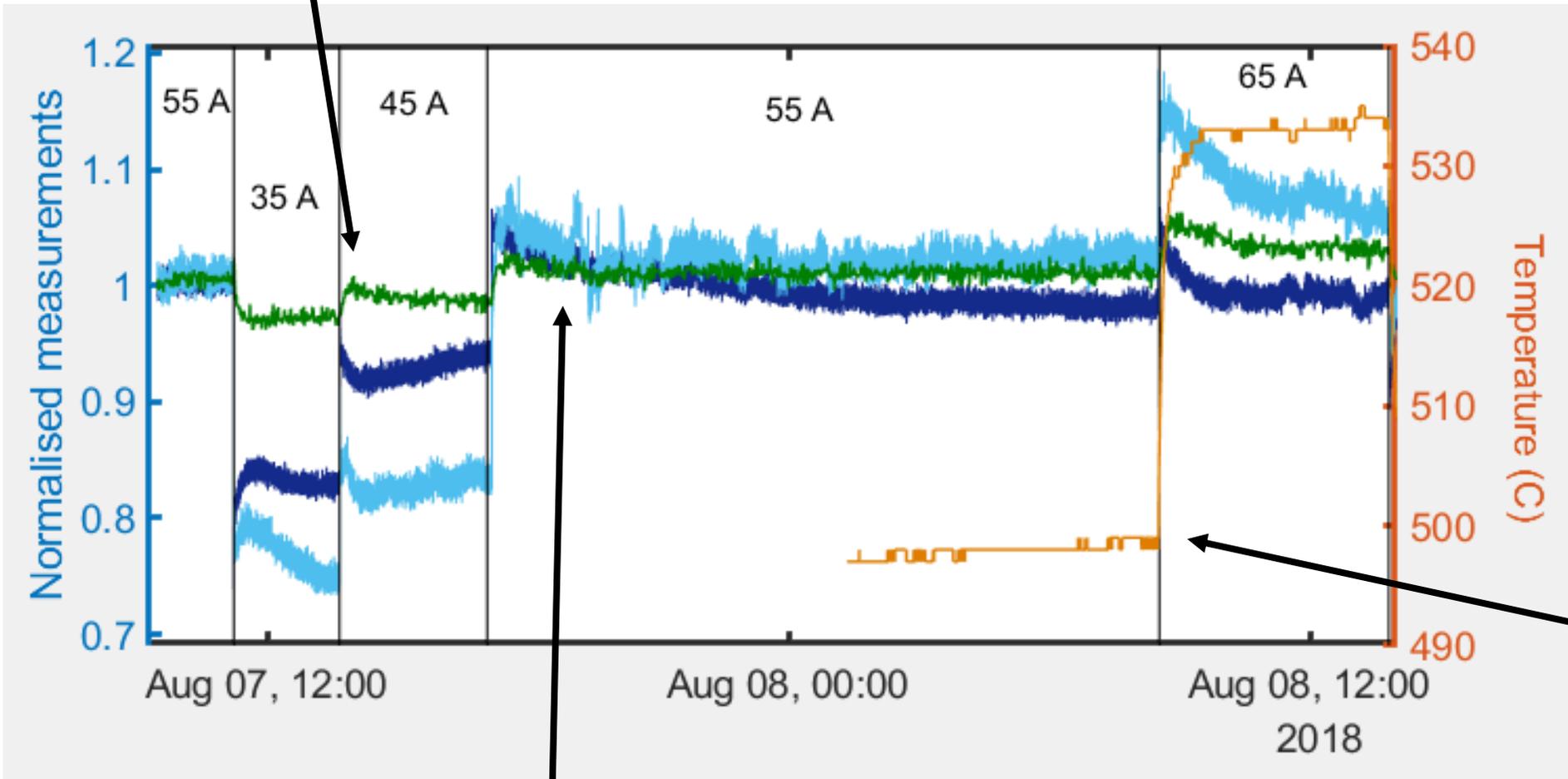
Cathode temperature increases in steps observed but not recorded due to controls network maintenance

Cs line, QCM, and  $H\beta$  all increase in bumps, tailing off at increased values



# Discharge current (2)

Temporary increase, as before



- Cathode Temp
- QCM Rate
- H $\beta$
- Cs 852 nm

Expect similar behaviour to air flow tests, superposed with something else

Unsure why QCM settles at new values



# Characterisation experiments: Summary

- Have a record of how observables change in response to sudden source changes
- Behaviour partially explained by presence of caesium reservoir
- Still lack understanding:
  - Why accumulation rate changes when oven doesn't
  - When arc voltage increases or decreases
  - When in or out of the pulse caesium leaves the surface and source



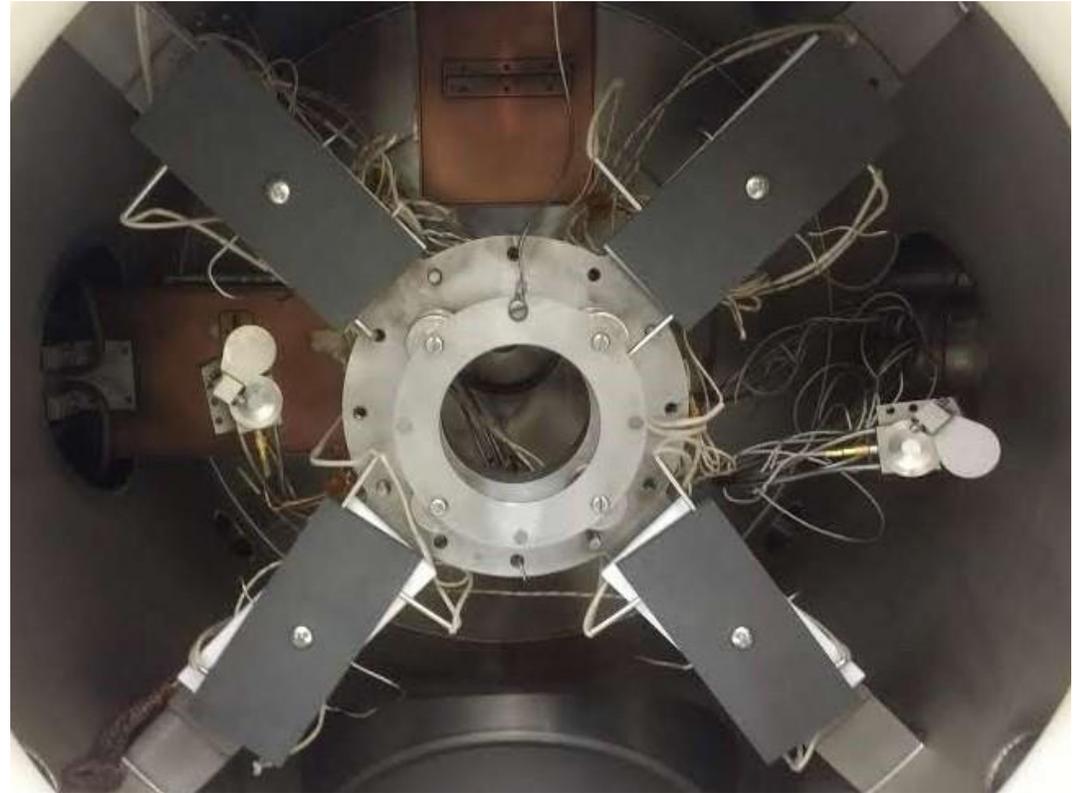
# Characterisation experiments: Next steps

- Repeat these experiments, tracking hydrogen ratio
- Use more QCMs
- Improve time resolution to see during and between pulses to learn when caesium
  - Escapes the source
  - Evaporates from the surface
- Fix position of QCMs and optics



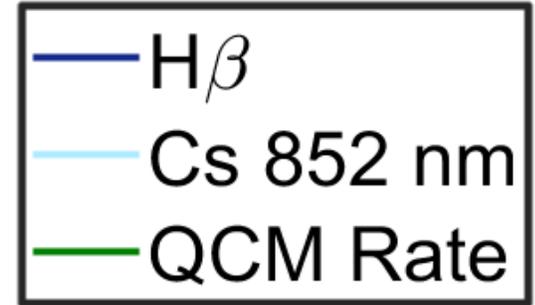
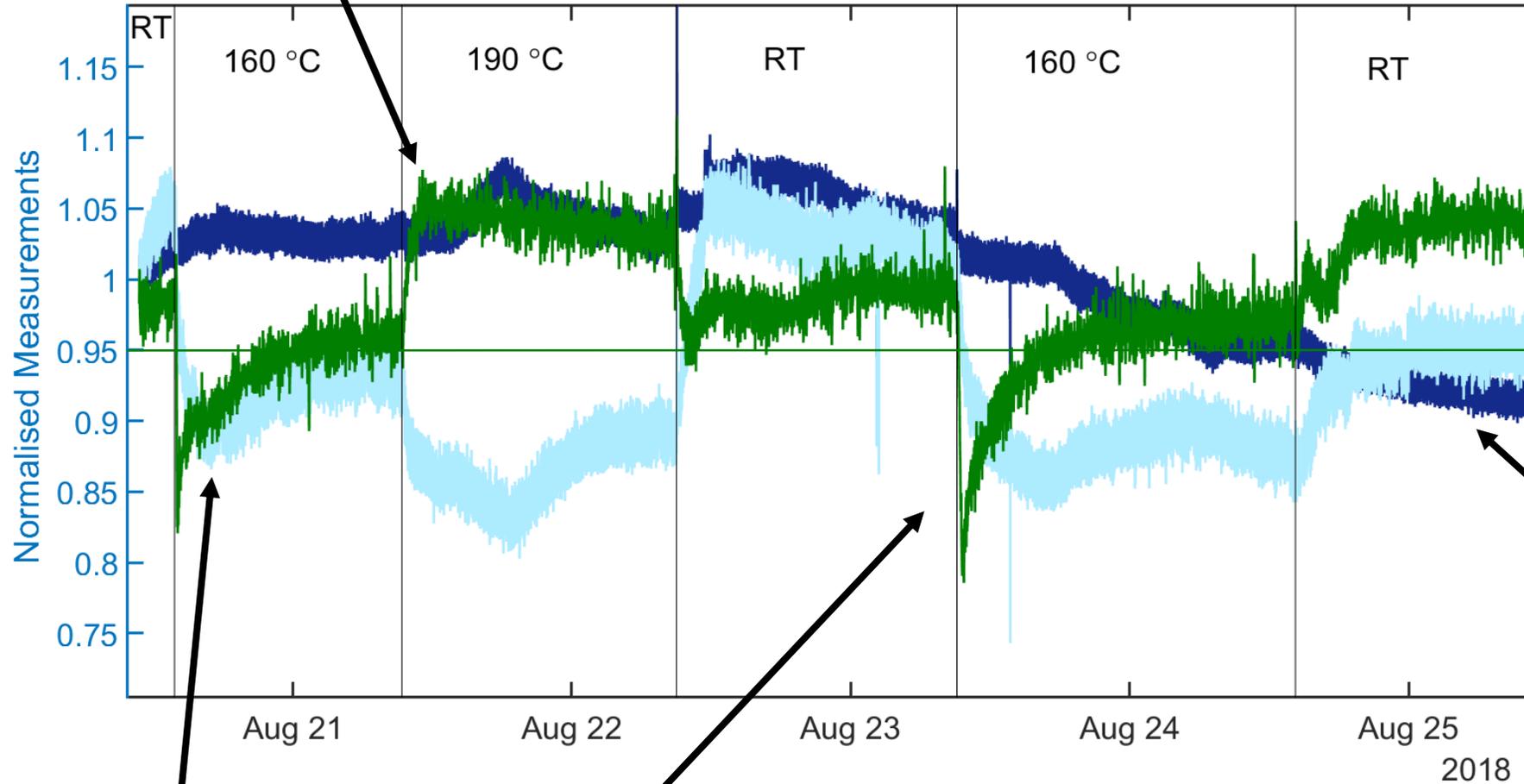
# Experiments with graphite

- Baked at 200 °C until changing the temperature had no effect on vessel pressure, indicating end of outgassing (2 days)
- Source started with graphite at room temperature, 160 °C and 190 °C
- Did not require changes to operational settings



# Experiments with graphite

At 190 °C QCM increases higher than at RT  
Cs line drops further



$H\beta$  does not demonstrate any clear trends

QCM rate sharply decreases, becoming negative when heated to 160 °C before flattening still lower than at RT



# Graphite experiments: Summary

- QCM accumulation and caesium line are clearly affected  
(Caesium in vessel)      (Caesium in plasma)
- Unclear how plasma light can be affected by graphite temperature
  - Related to caesium pressure in the vessel?
- Appears there is a temperature range around 160 °C where gettering occurs

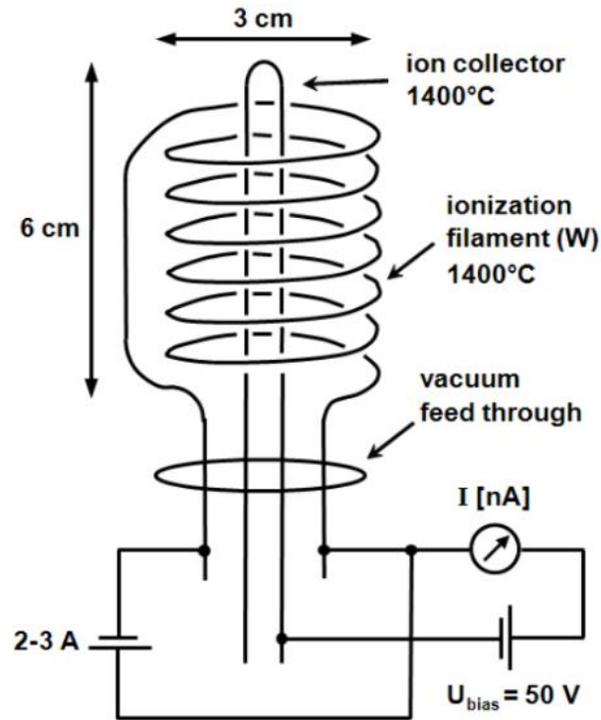


# Graphite experiments: Next steps

- As we speak other temperatures are being trialled
- Improve time resolution to observe during pulse
  - Could this help understand why light is affected?
- Fix QCM and optics with frame
- Use more QCMs



# Improving time resolution: Ionisation monitor

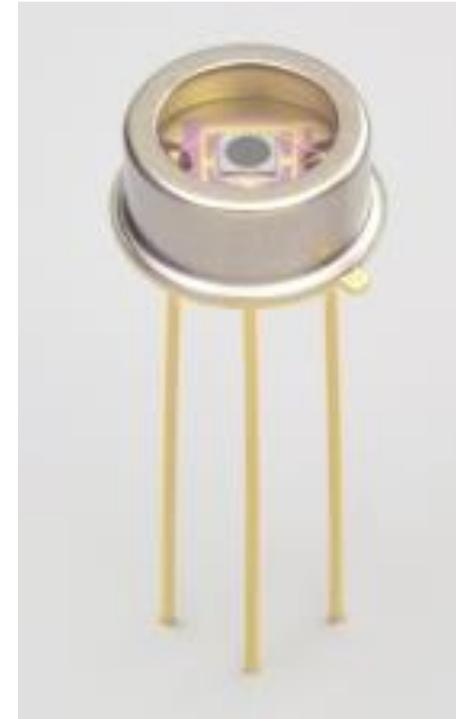


- Caesium deposited on the filament is ionized
- The measured current is proportional to the amount of incoming caesium

**Figure 4.8.:** Schematic illustration of a surface ionization detector (SID) consisting of the tungsten ionization filament and the biased ion collector.

# Improving time resolution: Optical kit

- Light collected through optical fibres
- Bandpass filters
- Silicon photomultipliers



# Conclusions

- Still very early
- Many unexpected results which don't yet have explanations
- Exciting early indications that graphite may reduce presence of caesium in the vessel motivate further investigation



Thank you for your attention

